

# Difrotec Product & Services

Ultra high accuracy interferometry &

custom optical solutions



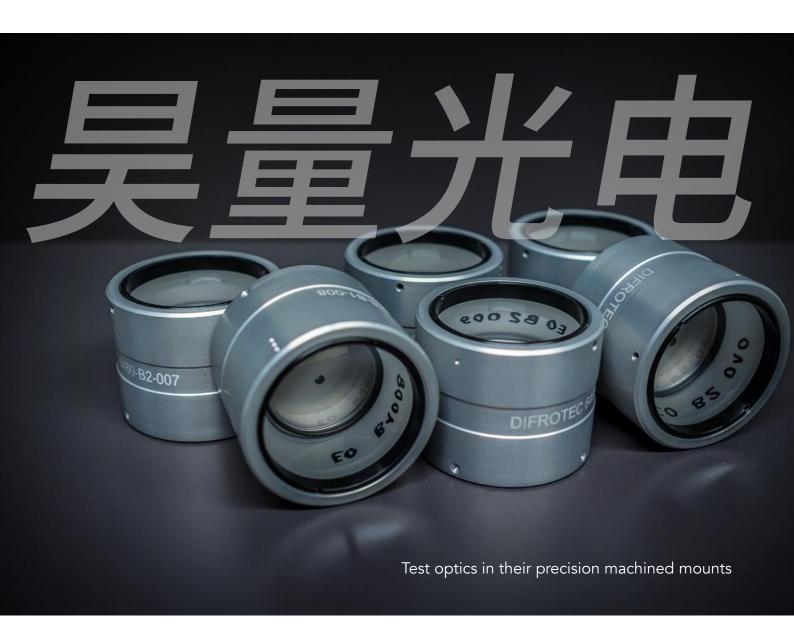


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# Overview

Interferometry is the first optical metrology method when obtaining the surface map with high precision. Difrotec launched a breakthrough innovation in interferometric measurements. A compact, user-friendly, reliable interferometer with accuracy greatly advancing the state-of-the-arts.



# Interferometer D7

Difrotec's interferometer D7 being the flagship of accuracy on interferometry market is an instrument which measures the form of optical surfaces and wavefronts. Difference between the measured and real forms is below 0.6 nm. It is the D7's accuracy value.

D7 is a standalone hardware that comes along with a fringe patterns processing software. DifroMetric.



1000



D7 is compact, reliable, and easy to use

## World record!

The interferometer D7 provides a world record accuracy 0.6 nm or 6 Ångström with an excellent repeatability

# Technology

D7 is phase shifting common path point diffraction interferometer (PSPDI). While the common Fizeau interferometers require reference optics, generating additional errors and masking surface details, D7 produces perfect reference – wavefront diffracted from a pinhole (sub-wavelength aperture in a thin metal film). D7 is patent pending.

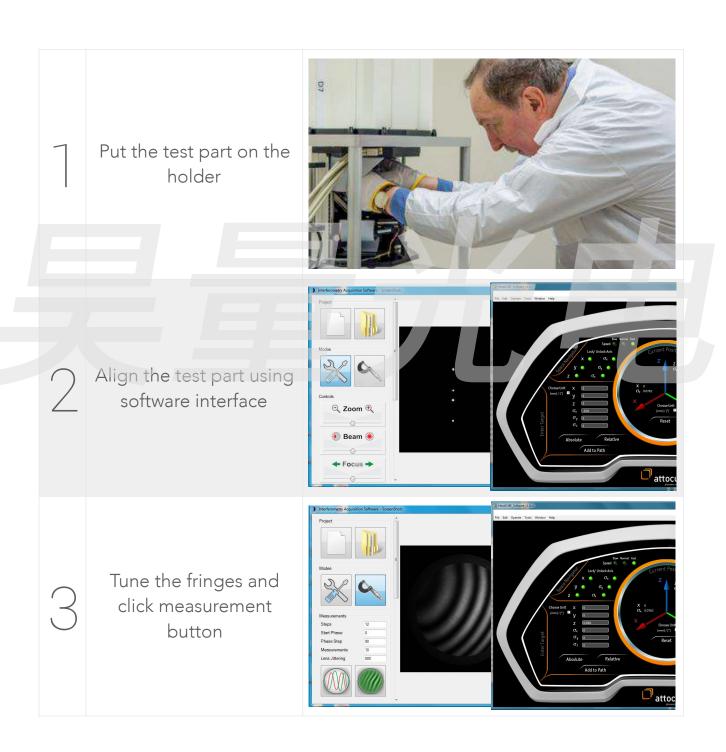
# Benefits

Advantages	Benefits
Ideal reference: no propagating error from using physical references	<ul> <li>Saving time because no need to change a large number of references;</li> <li>Saving cost because no need to buy expensive reference kit</li> </ul>
100 times higher accuracy over standard performance transmission spheres used in Fizeau interferometers	- Saving time & cost because intermediate instruments or additional methods to improve accuracy are not required
The D7 inspects more of the surface features than other interferometers	- Saving cost due to better revealing manufacturing mistakes before installation and launch of optical systems
Stability and robustness	<ul> <li>Saving time because excellent repeatability provides results which do not need continuous proof;</li> <li>Saving cost because D7 does not require special environment conditions</li> </ul>
Wide range of applications	- Saving time & cost due to compact and simple set-up for using in a lab or on factory floor (in-situ) with vertical and horizontal orientation
No retrace errors	- Saving time & cost due to simplified set-ups when measuring asphere and freeforms



# Measurements

Measuring an optics with D7 can be done is 3 simple steps

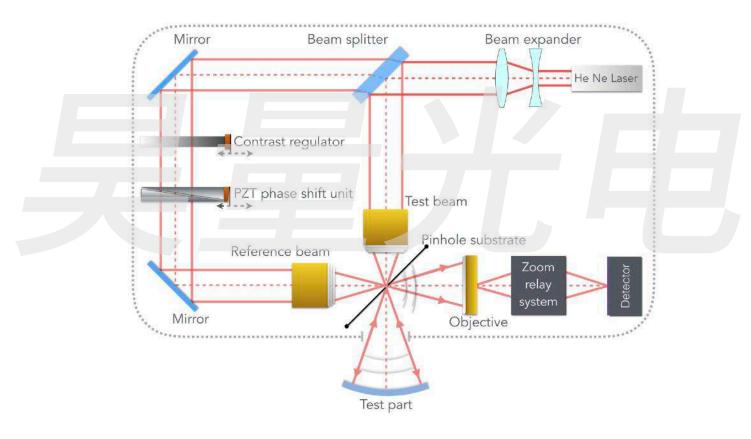


# Specifications

Performance		
Accuracy:	≤0.6 nm (\(\lambda/1000\))	
Wavefront RMS repeatability:	≤0.23 nm (λ/2800)	
Acquisition time:	10 milliseconds	
Optical		
System clear numerical aperture (NA):	0.6 (F# 0.83)	
System imaging numerical aperture (NA):	0.55 (F# 0.91)	
Image zoom system:	4× optical zoom controlled by software interface	
Imaging:	Coherent (no diffuser glass) with artifacts removal option	
CCD camera:	0.5k × 0.5k (optional: 1k x 1k, 2k x 2k or 5k x 5k)	
Height resolution:	λ/8000	
Pixels depth (digitization):	12 bits	
Exposure time:	40 μs minimum	
Sensor pixel resolution:	500 × 500 on ≥50 mm diameter	
	part	
Focus control:	Motorized & controlled through software interface	
Optical focus range:	± 2 meters	
Illumination		
Laser type and wavelength:	Stabilized He-Ne, 632.8 nm	
Laser power:	2 mW (higher power available on demand)	
Polarization:	Adjustable test surface properties	
Coherence:	≥100m	
System		
Data acquisition:	Phase shifting interferometry (PSI) or Static	
PSI method:	PZT electronic phase shifting	
Alignment range:	± 2.5 deg.	
Alignment type:	Dual spot	
Alignment reticle:	Computer generated	

# D7 has no physical reference optics

#### Working principle of D7 (specific schematic withheld)



Two-beam phase shifting point diffraction interferometer provides a major advantage over other schemes by availing two independently steerable beams. Here, the test beam and reference beam are perpendicular to each other, where the intensity of the reference can be regulated. Concave shapes can be measured directly, whereas other kinds of optics are measured using a non-precise accessory. Please refer to our website, <a href="https://www.difrotec.com">www.difrotec.com</a> and brochure for detailed configurations.

# Applications



Difrotec's D7 aims to verify existing Fizeau interferometers. Due to its reference-less design D7 is well suited for testing high precision optics with complex forms and large aspheric departure. D7 is compact, reliable and user-friendly interferometer and equally excellent to measure common optics.

#### Wavefront Quality

- Projection lenses
- Telescopes
- Microscopes
- Photo lenses



### Radius of Curvature

 Combining long distance sensors with the highest focusing accuracy provided by D7 gives ppm RoC accuracy

## Optical Surface Quality

- Spheric
- Flats
- Corner cubes
- Aspheres
- Freeforms
- Reference optics

#### Image Quality

 Validate the resolving capacity of your optics before deployment.

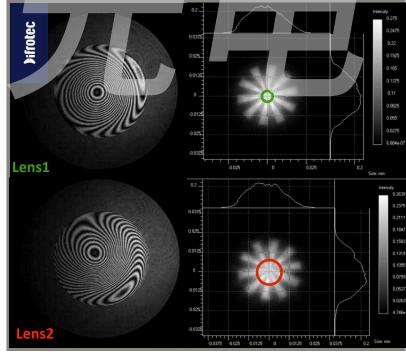
# Application cases Measurement cases with D7 D7 found a significant difference between two identical lenses and predicted a reduction of resolution by 3 times. Being able to validate the image quality from orbit is crucial for the mission.

#### 1. Validating image quality of a space camera

Difrotec tested two lenses for Tartu
Observatory, Lens 1 & Lens 2, for space
satellite Student Earth Orbiter (ESEO).
Department of Space Technology wanted
to verify if the lenses were on par with the
given specification so as to render the
highest quality image after being launched
520 km into space.

D7 found that two supposedly identical lenses were quite different in terms of wavefront quality, and the image resolution was 3 times worse. D7 distinguished the quality difference between lenses having wavefront aberrations 3  $\lambda$  with accuracy  $\lambda$ / 1000. Lens1 resolves 20 meters per pixel, whereas Lens2 60 meters per pixel from the working distance of 520 km.

It helped Tartu Observatory to choose and fine tune the satellite camera assembly before an expensive launch.

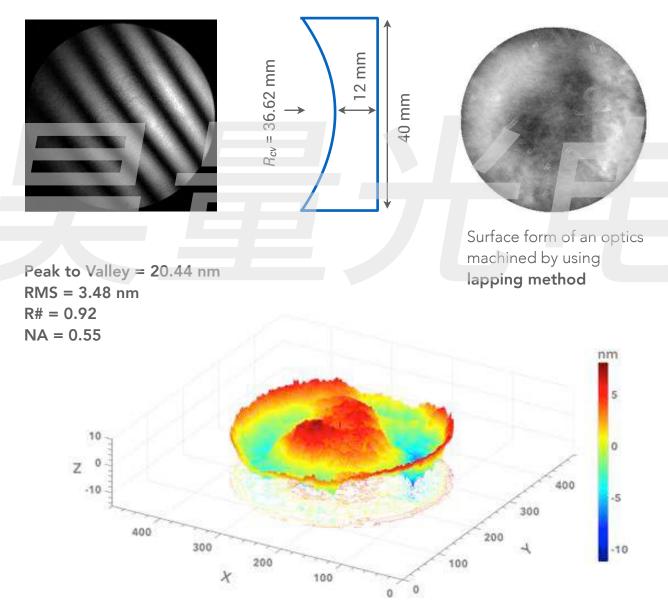


Fringe patterns and simulated Siemens star help determine image resolution for optics.

#### 2. Revealing optics machining residue

Optical surfaces are machined to a certain shape by various methods such as pitch polishing and lapping. They leave residue that affect the performance of produced optics. Commonly, when residue heights do not exceed several nanometers, residues are not seen from the surface map provided by a Fizeau interferometer. D7 investigates deep and reveals shape forming technology.

#### Shape formed by lapping

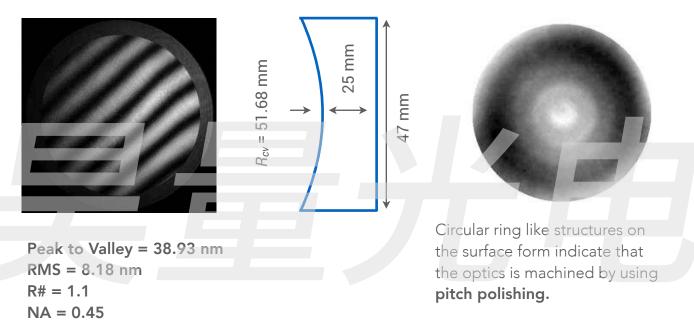


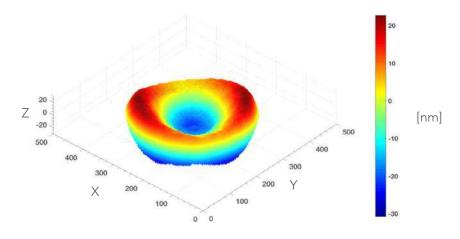
A typical pattern of lapping residues contains smoothed random irregular features.

#### Shape formed by pitch polishing

Pitch polishing is often used to shape optics. This is done in multiple steps, where the accuracy of the CNC lathe is successively increasing. A cutter head with diamond finishes the surface. The turning motion of the lathe and the contact approach repeats the defects during the finishing giving rise to ring like structures on the form.

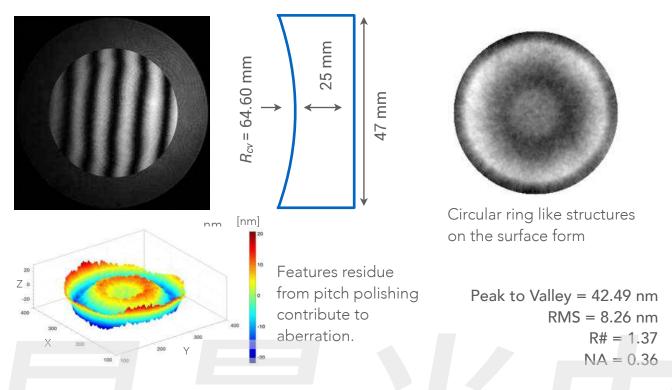
#### Surface 1





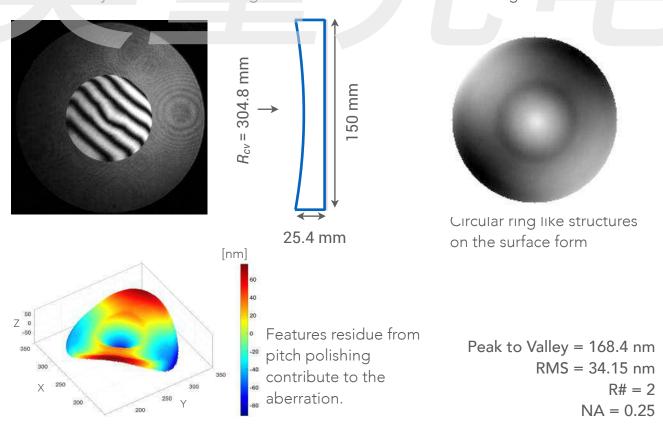
Features residue from pitch polishing machining process appears as shallow circular patterns which contribute to aberration but cannot be always clearly seen using standard Fizeau interferometers.

#### Surface 2



#### Aluminum coated spherical mirror

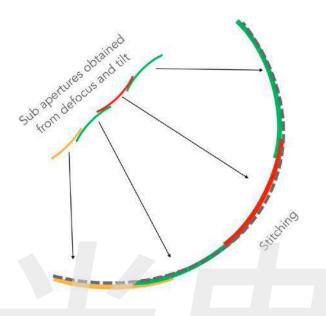
D7 is similarly effective in revealing the features residue from machining in mirrors.



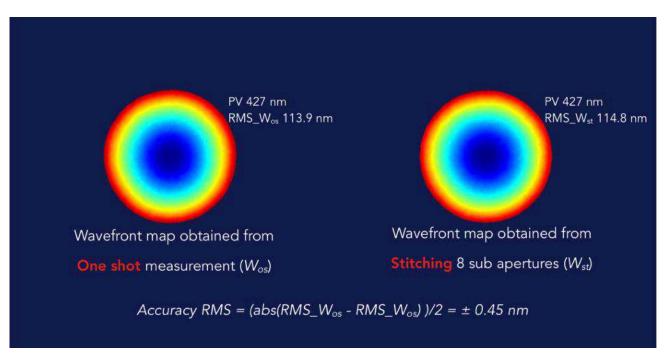
# Stitching

#### Over sized optics and aspheres

- Large spherical concave of R# ≥ 0.9 can be directly measured by putting D7 farther away.
- Optics with larger aperture require accessories.
- For aspheres and freeform we use high accuracy sub aperture stitching (SAS)
  - D7 has greater accuracy reserve to match overlays.
  - Easier to align and no retrace errors preserve accuracy throughout stitching.

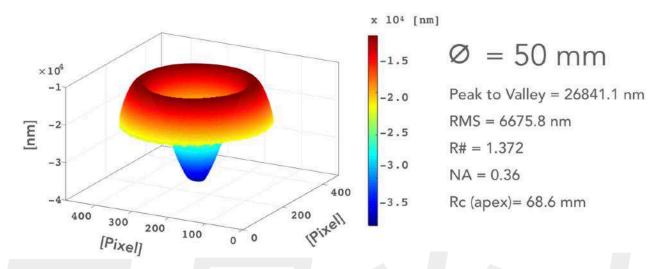


#### Testing the reliability of stitching



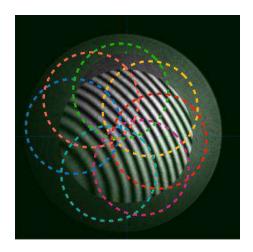


#### Asphere concave stitched

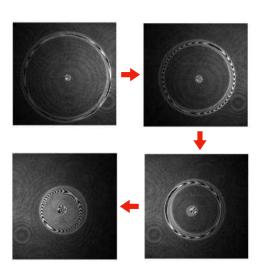


#### Stitching

Our algorithm does not involve stage parameters or any special scanning procedure as long as there is an overlap of over 50% between successive sub-apertures. This means, sub-apertures can be obtained by z-axis scanning, lateral scanning, radial scanning or linear scanning (for longer slabs).



Fringes are captured by rotating the test part at a certain angle around optical axis to provide sufficient overlay.



Fringes are captured by z-axis scanning, i.e. changing defocus to measure above asphere.



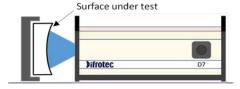
#### **Optical testing**

#### Type of optics

#### Concave optics

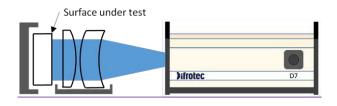
D7 can measure them directly (without accessories) out of the box.

#### Configuration



#### Flat surface

Flats can be measured with a beam converging accessory DA-1. The impact of accessory is calibrated and eliminated on-line during measurements.

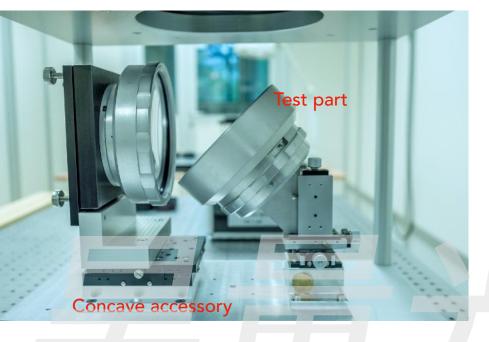


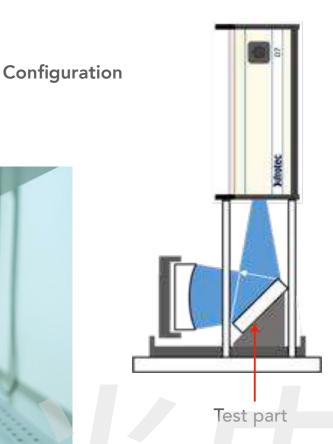
#### Services / optical testing

#### Type of optics

#### Flat surfaces

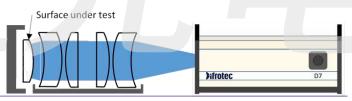
Flats can be measured in a semi direct fashion.





#### Convex surfaces

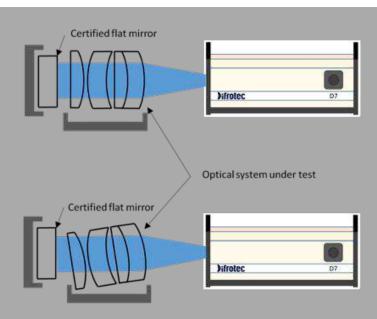
Convex optical surfaces can be measured with a beam converging accessory DA-1



#### Wavefront quality

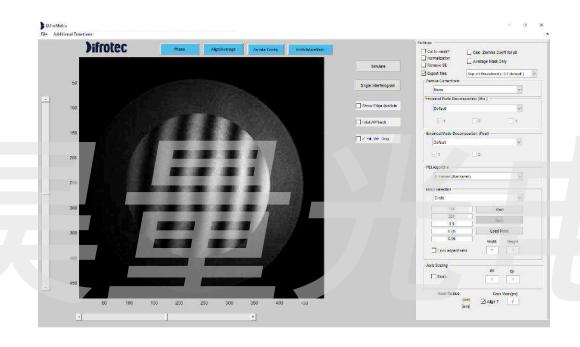
Testing wavefront transmitted from optical system

\*Unlike in the case of transmission spheres, effect of accessory is canceled by design of D7 and has no influence on the measured wavefront of the test part.



# DifroMetric

DifroMetric is feature rich fringe analysis software made by Difrotec. DifroMetric is OS/platform independent and can take and produce most of the data formats common in the field of interferometry. Processing steps are automated, which saves time while analyzing thousands of interferograms.



#### Main functions

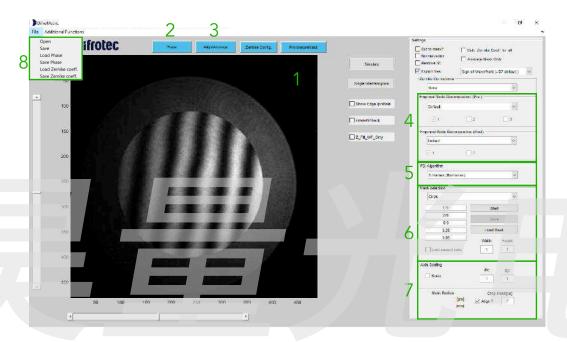
- 1. Fringe pattern and wavefront image processing
- 2. Circular, elliptical, rectangular and custom mask generating
- 3. Wavefront computation based on vibration resistant methods of phase retrieval
- 4. Zernike fitting of measured wavefronts
- 5. Intelligent averaging wavefronts to damp spare reflections effects (SRE)
- 6. Intelligent averaging wavefronts to eliminate system error of the interferometer
- 7. Wavefront arithmetics developing
- 8. Sub-apertures lattice arrangement developing
- 9. Sub-aperture wavefronts smart stitching developing
- 10. Processing benchmark data of the interferometer performance

#### DifroMetric / main functions

**Each function contains default and user settings**, and offers custom combination of numerous opportunities of interferometric data analysis

**Various additional functions** including fringe pattern normalization, loading/saving settings, Zernike coefficients and diagrams, tracking actual phase error, et al.

#### **Main Window**

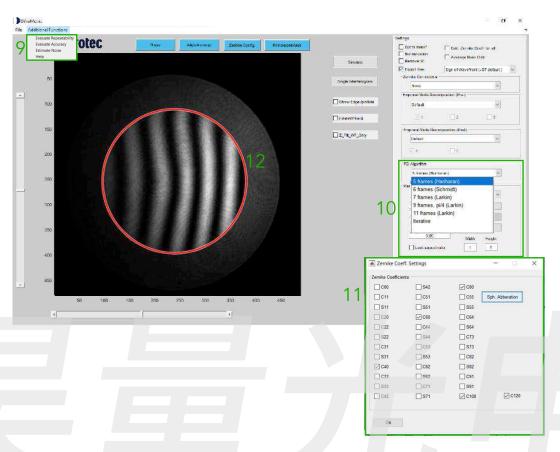


#### Features (base options)

- 1. Fringe pattern window
- 2. Phase button launches phase retrieval procedure
- 3. Intelligent averaging button runs system error elimination procedure
- 4. Image processing options
- 5. Selection of phase retrieval method
- 6. Setting mask type and parameters
- 7. Intelligent averaging parameters
- 8. Drop-down file menu allows to open necessary sets of phase shifting frames, open/save retrieved wavefronts and their Zernike fitting

#### DifroMetric / main functions

#### More built in options

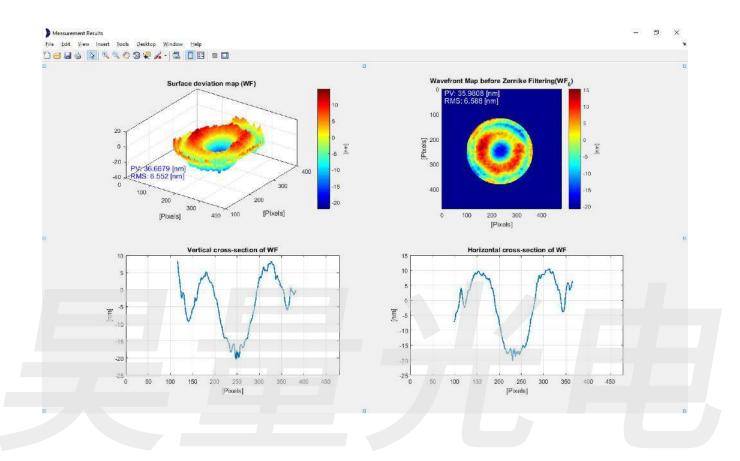


#### Features (additional options)

- 9. Drop-down additional options menu of the pre-installed interferometer performance auto-testing
- 10. Selecting Phase Retrieval method
- 11. Settings for Zernike fitting
  - a. User can manually set the combinations
  - b. User can also perform a reverse Zernike correction
- 12. Loading the mask
  - a. Circular
  - b. Elliptical
  - c. Rectangular

#### DifroMetric / main functions

#### Displaying results



- Surface deviation map
- Cross sections in x and y axes
- Zernike coefficients in \*.csv format
- Result images in \*.fits format (can be customised to other formats)
- Intermediate, as well as averaged results are automatically saved